TRANSMITTAL FORM			Application Number Filing Date		Serial No. 09 826,098 1 15		
					April 5, 2001		
(to be used freall correspondence after initial filing)			First Named Inventor		Takeshi YAMASHITA et al.		
AUG 2 7 2003			Group Art Unit		Group Art Unit: 1765		
			Examiner Name		Examiner: Kin Chan Chen		
Pages in This Submission			Attorney Docket Number		740819-537		
		FNCLOSE	RES (check all that apply)				
Fee Attached Drawl Amendment Reply Decla After Final Licen Affidavits declaration(s) Petitic Extension of Time Request Appli Express Abandonment Request Power Information Disclosure Statement Terms Certified Copy of Priority Document(s)		Orawing	tion and Power of Attorney ng-related Papers to Convert to a Provisional		After Allowance Communication to Group Appeal Communication to Board of Appeals and Interferences Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Application Data Sheet Request for Corrected Filing Receipt with Enclosures A self-addressed prepaid postcard for acknowledging receipt		
		Reques			Other Enclosure(s) (please identify below): Verified English Translation of Priority Document JP 2000-117502		
		Remarks	The Commissioner is hereby authorized to charge any additional fees required or credit any overpayments to Deposit Account No. 19-2380 for the above identified docket number.				
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Firm or Individual name	Nixon Pea 401 9 th Str Suite 900	Donald R. Studebaker, Reg. No. 32,815 Nixon Peabody LLP 401 9 th Street, N.W. Suite 900 Washington, D.C. 20004-2128					
Signature	1	2-111					
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n re Patent Application of:)		IJ
Takeshi YAMASHITA et al.)	Group Art Unit: 1765	TC SEP OEC
Serial No. 09 826,098)	Examiner: Kin Chan Chen	
Filed: April 5, 2001)	Confirmation No. 2729	VEI 2003 700
For: DRY ETCHING METHOD, FABRICATION METHOD FOR SEMICONDUCTOR DEVICE, AND)	Date: August 27, 2003	0 8 0

CERTIFICATE OF MAILING OR TRANSMISSION [37 CFR 1.8(a)]

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DRY ETCHING APPARATUS

Sir:

In response to the Office Action mailed May 28, 2003, please consider the following amendments and remarks in connection with the above-identified application.